TFW 2811



Attorney Docket SEL 189

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of	)	Ιl
Takayama et al.	)	er C
Serial No.: 09/598,736	)	P
Filed: June 21, 2000	)	_
For: Wiring Material, Semiconductor Device Provided With A Wiring Using The Wiring Material And Method Of Manufacturing The		$\frac{\zeta}{Si}$
Art Unit: 2811	)	
Examiner: Hung K. Vu	)	
Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450		

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

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P.O. Box 1450, Alexandria, VA 22313-1450 on

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Signature

Date

**AMENDMENT (G)** 

Sir:

In response to the Office Action of March 24, 2006, please amend the above-identified application as follows: